

<b>Notice of References Cited</b>	Application/Control No. 09/908,992	Applicant(s)/Patent Under Reexamination SYKEN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Han et al, Sequence ID AF244136, GenEmb1, 2000 April 30.
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